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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/234,233	01/20/1999	WEIMIN LI	MI22-1035	6381
21567	7590	10/07/2004	EXAMINER	
WELLS ST. JOHN P.S. 601 W. FIRST AVENUE, SUITE 1300 SPOKANE, WA 99201			VU, DAVID	
			ART UNIT	PAPER NUMBER
			2818	

DATE MAILED: 10/07/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

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APPLICATION NO./ CONTROL NO.	FILING DATE	FIRST NAMED INVENTOR / PATENT IN REEXAMINATION	ATTORNEY DOCKET NO.
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EXAMINER

ART UNIT	PAPER
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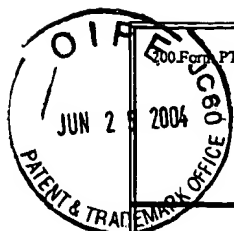
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Commissioner for Patents

Attached is a copy of the IDS dated 06/25/04 which has been considered by the examiner:


David Helms
Supervisory Patent Examiner
Technology Center 2800



200 Form PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
MI22-1035SERIAL NO.
09/234,233LIST OF ART CITED BY APPLICANT
(Use several sheets if necessary)APPLICANT
Weimin LiFILING DATE
January 20, 1999GROUP
2818

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
DV	AA	4,971,655	11-90	Stefano et al.			
	AB	6,498,084B2	12-02	Bergemont			
	AC	5,036,383	07-91	Mori			
	AD	6,638,875	10/03	Han et al			
	AE	6,720,247	04/04	Kirkpatrick et al			
	AF	6,723,631	04/04	Noguchi et al			
	AG	6,627,535	09/03	MacNeil et al			
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	AJ	2003/0207594	11/03	Catabay et al			
DV	AK	2004/0071878	04/04	Schuhmacher et al			

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		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
DV	AL	08-045926A	2/96	Japan				
	AM	JP8051058	02/96	Japan				
	AN	JP63316476	12/88	Japan				
DV	AO	JP8078322	03/96	Japan				

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

DV	AP		Wolf, S., Silicon Process., Vol 3 pg. 635
	AQ		
	AR		

EXAMINER

gundano

DATE CONSIDERED

09/29/04

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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